

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

---

Applicant(s): Cleeves et al.	Group Art Unit: 2814
Application No.: 10/681,509	Examiner: Howard Weiss
Filed: 10/07/2003	
Title: Uniform Seeding to Control Grain and Defect Density of Crystallized Silicon for Use in Sub-Micron Thin Film Transistors	
Attorney Docket No.: SAND- 01135US0 (formerly MA-108)	

---

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

December 22, 2006

**PETITION UNDER 37 CFR 1.182: CHANGE ORDER OF INVENTOR NAMES**

Applicants, through their undersigned agent, hereby petition the Commissioner to change the order of the names of the inventors in the above-identified application. The prior order of inventor names was made in error in an application data sheet filed with the application. The actual inventors are not changed, and no inventors are added or removed. Only the order of the names is intended to be changed.

The **INTENDED** order of the inventor names, which appears on the original declaration as filed, is as follows:

(1) Shuo Gu

(2) James M. Cleeves

The petition fee set forth in 37 C.F.R. §1.17(f) is provided in the amount of:

\$400.00.

An application data sheet including inventor names in the correct order is included.

December 22, 2006

Date

/Pamela J. Squyres/

Pamela J. Squyres, Reg. No. 52246  
Agent for Applicants

Pamela J. Squyres  
Vierra, Magen, Marcus & DeNiro  
575 Market St., Suite 2500  
San Francisco, CA 94105  
Tel. 415-369-9660